Notes

Practical example: diffraction Eugeniy E. Mikhailov The College of William & Mary Sec Lecture 11

According to Huygens' principle, every point on the mask is a secondary source. Thus, the electric field magnitude at a target is

$$egin{aligned} \mathcal{E}_{target}(ec{r}) &\sim \int \int_{mask} dx' dy' rac{\mathcal{E}_{mask}(x',y')}{|ec{r}-ec{r}'|} e^{ik|ec{r}-ec{r}'|} \end{aligned}$$

We assumed that both the mask and the target are parallel to the x - y plane and that $\vec{r} - \vec{r'}$ is mostly parallel to *z* axis. Here

- $\vec{r} = (x, y, z)$ is the radius vector pointing to the target point,
- $\vec{r}' = (x', y', z')$ is is the radius vector pointing to the mask/source,

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• $k = \frac{2\pi}{\lambda}$ is the magnitude of *k*-vector.

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Diffraction

Diffraction approximation via sum

$$E_{target}(\vec{r}) \sim \sum_{i} \sum_{k} \Delta x' \Delta y' rac{E_{mask}(x'_i, y'_k)}{|\vec{r} - \vec{r}'|} e^{ik|\vec{r} - \vec{r}'|}$$

Here

$$\vec{r} = x, y, z$$

 $\vec{r}' = x'_i, y'_k, z'$
 $\vec{k} = \frac{2\pi}{\lambda}$

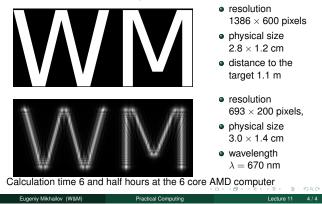
It is important that the integrated function does not oscillate wildly from one sample point to another sample point. So, we need $\Delta x'$ and $\Delta y' \ll \sqrt{L\lambda}$, where *L* is distance between the mask and the target.

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Sample of diffraction

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Let's consider a diffraction of light on a mask shown below.



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